

## IN THE CLAIMS

Please amend Claims 1-19, to read as follows.

1. (Currently Amended) A method for manufacturing an electron source substrate ~~having a construction capable of arranging~~ configured so that an anode member ~~[[to]] confronts through~~ a spacer, comprising the steps of:

forming a plurality of electrode pairs over ~~[[the]] a~~ substrate, each electrode pair comprising two individual electrodes;

forming conductive films by applying liquid droplets containing a conductive substance between the individual electrodes of ~~[[the]] each electrode pairs with pair,~~ using a plurality of ink jet devices heads; and

forming an electron emission portion in each of the conductive films,

wherein ~~at the time of applying the liquid droplets,~~ at least for those of the electrode pairs arranged in the vicinity of the ~~fixed portion of the~~ spacer, ~~there is used the~~ liquid droplets are applied by an ink jet device head of a kind different from that used for the ~~remaining other~~ electrode pairs.

2. (Currently Amended) The method according to Claim 1,

wherein the ink jet ~~device which~~ head that is used at least for the electrode pairs arranged in the vicinity of the ~~fixed portion of the~~ spacer has a higher performance than that used for the ~~remaining other~~ electrode pairs.

3. (Currently Amended) The method according to Claim 2,  
wherein the ink jet ~~device which~~ head that is used at least for the electrode pairs  
arranged in the vicinity of the ~~fixed portion of the~~ spacer has a higher drop placement  
accuracy than that used for the ~~remaining~~ other electrode pairs.

4. (Currently Amended) The method according to Claim 2,  
wherein the ink jet ~~device which~~ head that is used at least for the electrode pairs  
arranged in the vicinity of the ~~fixed portion of the~~ spacer has a higher drop volume accuracy  
than that used for the ~~remaining~~ other electrode pairs.

5. (Currently Amended) The method according to Claim 1,  
wherein the ink jet ~~device which~~ head that is used at least for the electrode pairs  
arranged in the vicinity of the ~~fixed portion of the~~ spacer has a nozzle arrangement different  
from that of the ink jet head used for the ~~remaining~~ other electrode pairs.

6. (Currently Amended) The method according to Claim 1,  
wherein the ink jet ~~device which~~ head that is used at least for the electrode pairs  
arranged in the vicinity of the ~~fixed portion of the~~ spacer has a ~~smaller nozzle number~~ fewer  
nozzles than that used for the ~~remaining~~ other electrode pairs.

7. (Currently Amended) The method according to Claim 1,

wherein the liquid droplets are substantially simultaneously applied to the electrode pairs arranged in the vicinity of the ~~fixed position of the~~ spacer and the ~~remaining~~ other electrode pairs.

8. (Currently Amended) The method according to Claim 1,  
wherein there is used a unit, in which ~~[[the]]~~ individual ink jet heads of a plurality of kinds ~~of ink jet devices~~ are connected.

9. (Currently Amended) The method according to Claim 8,  
wherein in the ~~used~~ unit used, the ink jet ~~devices~~ heads for the ~~remaining~~ other electrode pairs are individually fixed on ~~[[the]]~~ two sides of the ink jet ~~device~~ head for the electrode pairs arranged in the vicinity of the ~~fixed position of the~~ spacer.

10. (Currently Amended) The method according to Claim 9,  
wherein the liquid droplets are applied while the unit and/or the substrate are being moved relative to ~~each other~~ one another along the ~~spacer arranging~~ direction in which the spacer is arranged.

11. (Currently Amended) A method for manufacturing an electron source substrate to be used in an image display device, comprising the steps of:  
forming a plurality of electrode pairs over ~~[[the]]~~ a substrate, each electrode pair comprising two individual electrodes;

forming conductive films by applying liquid droplets containing a conductive substance between the individual electrodes of ~~[[the]]~~ each electrode ~~pairs with pair~~, using a plurality of ink jet ~~devices~~ heads; and

forming an electron emission portion in each of the conductive films,

wherein ~~at the time of applying the liquid droplets~~, at least for those of the electrode pairs arranged at ~~the screen central portion~~, there is used a central portion of a screen of the image display device, the liquid droplets are applied by an ink jet device head of a kind different from that used for those of the electrode pairs arranged at ~~the screen end portion~~ an end portion of the screen of the image display device.

12. (Currently Amended) The method according to Claim 11,

wherein the ink jet ~~device which~~ head that is used at least for the electrode pairs arranged at the ~~screen~~ central portion of the screen has a higher performance than that used for the electrode pairs arranged at the ~~screen~~ end portion of the screen.

13. (Currently Amended) The method according to Claim 12,

wherein the ink jet ~~device which~~ head that is used at least for the electrode pairs arranged at the ~~screen~~ central portion of the screen has a higher drop placement accuracy than that used for the electrode pairs arranged at the ~~screen~~ end portion of the screen.

14. (Currently Amended) The method according to Claim 12,

wherein the ink jet ~~device which~~ head that is used at least for the electrode pairs arranged at the ~~screen~~ central portion of the screen has a higher drop volume accuracy than that used for the electrode pairs arranged at the ~~screen~~ end portion of the screen.

15. (Currently Amended) The method according to Claim 11,  
wherein the ink jet ~~device which~~ head that is used at least for the electrode pairs arranged at the ~~screen~~ central portion of the screen has ~~a smaller nozzle number~~ fewer nozzles than that used for the electrode pairs arranged at the ~~screen~~ end portion of the screen.

16. (Currently Amended) The method according to Claim 11,  
wherein the liquid droplets are substantially simultaneously applied to the electrode pairs arranged at the ~~screen~~ central portion of the screen and the electrode pairs arranged at the ~~screen~~ end portion of the screen.

17. (Currently Amended) A method for manufacturing an electron source substrate, comprising the steps of:

forming a plurality of electrode pairs over ~~[[the]]~~ a substrate, each electrode pair comprising two individual electrodes;

forming conductive films by applying liquid droplets containing a conductive substance between the individual electrodes of ~~[[the]]~~ each electrode ~~pairs with pair~~, using a plurality of kinds of ink jet ~~devices~~ heads; and

forming an electron emission portion in each of the conductive films.

18. (Currently Amended) A method for manufacturing an electron source substrate, comprising the steps of:

forming a plurality of electrode pairs over ~~[[the]]~~ a substrate, each electrode pair comprising two individual electrodes;

forming conductive films by applying liquid droplets containing a conductive substance between the individual electrodes of ~~[[the]]~~ each electrode ~~pairs with pair~~, using a unit~~[[,]]~~ in which ~~[[the]]~~ individual ink jet heads of a plurality of kinds ~~of ink jet devices~~ are connected; and

forming an electron emission portion in each of the conductive films.

19. (Currently Amended) A method for manufacturing an electron source substrate, comprising the steps of:

forming a plurality of electrode pairs over ~~[[the]]~~ a substrate, each electrode pair comprising two individual electrodes;

forming conductive films by applying liquid droplets containing a conductive substance between the individual electrodes of ~~[[the]]~~ each electrode ~~pairs with pair~~, using a plurality of ink jet ~~devices~~ heads; and

forming an electron emission portion in each of the conductive films,

wherein ~~at the time of applying the liquid droplets~~, for those of the electrode pairs arranged ~~[[at]]~~ in a predetermined region, ~~there is used~~ the liquid droplets are applied by an ink jet ~~device~~ head of a kind different from that used for those of the electrode pairs arranged at ~~the remaining~~ other regions.